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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JAN 03 2005

Applicant: DeLoach et al.

Art Unit: 2822

Serial No.: 10/703,387

Examiner: Thomas, T.

Filing Date: 11/06/2003

Docket No.: TI-35862

Customer No.: 23494

Conf. No.: 9996

Title: FORMING A TRENCH TO DEFINE ONE OR MORE ISOLATION
REGIONS IN A SEMICONDUCTOR STRUCTURE

CERTIFICATION OF FACSIMILE TRANSMISSION

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Jacqueline J. Garner, Reg. No. 36,144January 3, 2005
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FACSIMILE COVER SHEET

<input checked="" type="checkbox"/> FACSIMILE COVER SHEET	<input checked="" type="checkbox"/> AMENDMENT (7 Pages)
<input type="checkbox"/> NEW APPLICATION	<input checked="" type="checkbox"/> EOT 3mth (3 Pages)
<input type="checkbox"/> DECLARATION (# Pages)	<input type="checkbox"/> NOTICE OF APPEAL (# Pages)
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<input type="checkbox"/> CONTINUATION APP'N (# Pages)	
<input type="checkbox"/> DIVISIONAL APP'N	
NAME OF INVENTOR(S): De Loach	
TITLE OF INVENTION: Forming a Trench . . .	
TI FILE NO.: TI-35862	DEPOSIT ACCT. NO.: 20-0668
FAXED: 1/3/2005 DUE: JJG ATTY/SECY: JJG	
RECEIPT DATE & SERIAL NO.:	
Serial No.: 10/703,387	
Filing Date: 11/06/2003	
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Jan 03 05 02:14p Jacqueline J Garner

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AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Jacqueline J. Garner
Reg. No. 36,144

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 7/1/2004. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification**.

Amendments to the Claims are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings**.

The **Remarks** begin on page 7.